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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/842,975
				Filing Date	April 26, 2001
				First Named Inventor	Richard D. Harris
				Group Art Unit	2811
				Examiner Name	
				Attorney Docket Number	110003.97397
Sheet	1	of	4		

Examiner Signature  Date Considered 11/25/02

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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[110003.97397]



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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 4 Attorney Docket Number 110003.97397

Complete if Known

Application Number	09/842,975
Filing Date	April 26, 2001
First Named Inventor	Richard D. Harris
Group Art Unit	2811
Examiner Name	

RC 2803 MAIL ROOM
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OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
1	1	Toumazou, C. et al., n-step Charge Injection Cancellation Scheme for Very Accurate Switched Current Circuits, Electronic Letters, V.30 (9) 680-681: 1994.
4	2	Emmerich, H., et al., A Novel Micromachined Magnetic-Field Sensor, MEMS 99 IEEE Conference, January 17-21, 1999, IEEE Catalog No. 99ch36291c.
3	3	Madou, Marc, Fundamentals of Microfabrication, Chapters 2-4, CRC Press LLC, Boca Raton, FL: 1997.
4	4	Kovacs, Gregory T.A., Micromachined Transducers Sourcebook, Table of Contents, pp. 77-119 and Index, WCB McGraw-Hill, U.S.A.: 1998.
5	5	Teegarden, Darrell et al., How to Model and Simulate Microgyroscope Systems, IEEE Spectrum, 66-75, July 1998.
6	6	Emmerich, Harald et al., Magnetic Field Measurements with a Novel Surface Micromachined Magnetic-Field Sensor, IEEE Transactions on Electron Devices, V. 47 (5) 972-977, May 2000.
7	7	McGruer, N.E. et al., Electrostatically Actuated Microswitches; Scaling Properties, Solid-State Sensor and Actuator Workshop, Hilton Head Island, South Carolina, June 8-11, 1998, pp.132-135.
8	8	Miyajima, Hiroshi et al., High-Aspect-Ratio Photolithography for MEMS Applications, J. of Microelectromechanical Sys., V.4(4) 220-229, Dec. 1995.
9	9	Lu, Crist et al., A Monolithic Surface Micromachined Accelerometer with Digital Output, IEEE J. of Solid State Circuits, V. 30 (12) 1367-1373, Dec. 1995.
10	10	Chen, Ming-Jer et al., Weak Inversion Charge Injection in Analog MOS Switches, IEEE J. of Solid-State Circuits, V. 30 (5) 604-606, May 1995.
11	11	Lemkin, Mark A. et al., A Fully Differential Lateral S? Accelerometer with Drift Cancellation Circuitry, Solid-State Sensor and Actuator Workshop, Hilton Head, South Carolina, June 2-6, 1996, pp. 90-93.

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11/15/02

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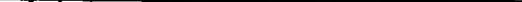
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<p>Sheet 3 of 4</p>		<p>Application Number 09/842,975</p>		<p>Filing Date April 26, 2001</p>	
<p><i>10 2001 10/10/01</i></p>		<p>First Named Inventor Richard D. Harris</p>		<p>Group Art Unit 2811</p>	
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